Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/779,712	FUJITA ET AL.	
Examiner	Art Unit	
Wen-Ying P. Chen	2871	

	SEAR	CHED	
Class	Subclass	Date	Examiner

INTERFERENCE SEARCHED				
Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Citations search of tagged references	12/13/2005	WPC		
349/155-157 combined with key word search of all databases in EAST	12/14/2005	WPC		
Reviewed previously cited references	12/14/2005	WPC		